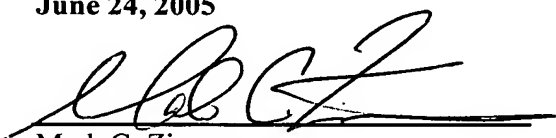


IFW



PATENT
Docket No. 20063/OG03-050

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

| | | |
|------------------------------|---|--|
| Applicant(s): |) | I hereby certify that this paper and the |
| |) | documents referred to as enclosed |
| Han et al. |) | therewith are being deposited with the |
| |) | United States Postal Service as first |
| U.S. Serial No.: 10/747,602 |) | class mail, postage prepaid, in an |
| |) | envelope addressed to Commissioner |
| For: "Methods of Fabricating |) | for Patents, P.O. Box 1450, |
| Semiconductor Devices" |) | Alexandria, Virginia 22313-1450 on |
| |) | this date: |
| Filed: 12/29/2003 |) | |
| |) | June 24, 2005 |
| Group Art Unit: 2812 |) | |
| |) |  |
| Examiner: Not Yet Assigned |) | Mark C. Zimmerman |
| |) | Attorney for Applicant(s) |
| |) | Registration No. 44,006 |

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

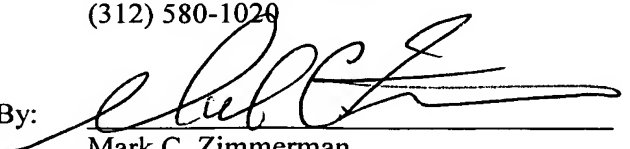
Sir:

Kindly advise when an Office action can be expected in the above-referenced matter.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC
USPTO Customer Number 34431
20 North Wacker Drive
Suite 4220
Chicago, Illinois 60606
(312) 580-1020

June 24, 2005

By: 
Mark C. Zimmerman
Registration No.: 44,006